



520.41003X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. KIMURA, et al.
Serial No.: 10/019,407
Filed: March 25, 2002
For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM
SUBSTRATE, MANUFACTURING METHOD OF THE
SAME, SEMICONDUCTOR DEVICE AND ELECTRONIC
DEVICE
Group: 2813
Examiner: Laura M. Schillinger

PETITION FOR EXTENSION OF TIME

Mail Stop: EOT
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 18, 2006

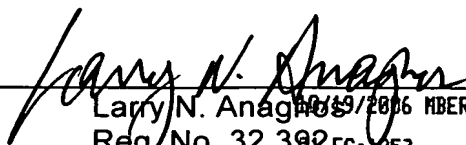
Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within a three-month time period subsequent to expiration of the response period set with the mailing of the new, non-Final Office Action, dated April 18, 2006. A credit card payment form in the amount of \$1,020.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (Docket No. 520.41003X00) and any excess fees credited to that account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

By 
Larry N. Anagnostis
Reg. No. 32,392 FC:1253

09/20/06 MBERHE 00000069 10019407

1020.00 0P

LNA/mlh
(703) 312-6600